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Author(s)	Ohtomo, Manabu; Tsuchida, Yuya; Muraya, Naoki et al.
Citation	The Journal of Physical Chemistry C, 117(22), 11555-11561 https://doi.org/10.1021/jp3117837
Issue Date	2013-06-06
Doc URL	https://hdl.handle.net/2115/56245
Type	journal article
File Information	jp3117837.pdf



In-Plane Orientation Control of 2,7-Diphenyl[1]benzothieno[3,2-*b*][1]benzothiophene Monolayer on Bismuth-Terminated Si(111) Vicinal Surfaces with Wettability Optimization

Manabu Ohtomo,^{*,†,‡,§} Yuya Tsuchida,[†] Naoki Muraya,[†] Takashi Yanase,[†] Seiji Sakai,[§] Tetsu Yonezawa,^{||} Taro Nagahama,[†] Tetsuya Hasegawa,^{‡,⊥} and Toshihiro Shimada^{*,†,⊥}

[†]Division of Materials Chemistry, Faculty of Engineering, Hokkaido University, Kita 13 Nishi 8, Sapporo, Hokkaido 060-8628, Japan

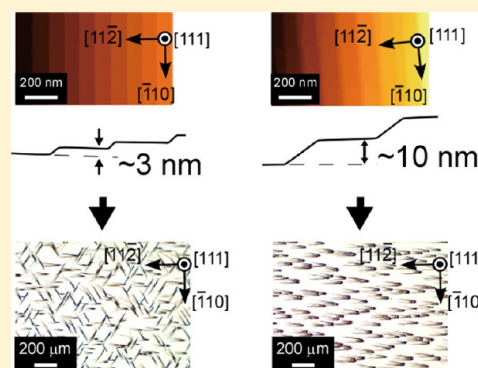
[‡]Department of Chemistry, Graduate School of Science, The University of Tokyo, Hongo 7-3-1, Tokyo 113-0033, Japan

[§]Advanced Science Research Center, Japan Atomic Energy Agency, 2-4 Shirakata-Shirane, Tokai, Ibaraki 319-1195, Japan

^{||}Division of Materials Science and Engineering, Faculty of Engineering, Hokkaido University, Kita 13 Nishi 8, Sapporo, Hokkaido 060-8628, Japan

[⊥]CREST-JST, Gobancho, Chiyoda-ku, Tokyo 102-0076, Japan

ABSTRACT: We report the in-plane orientation control of a high-mobility organic semiconductor: 2,7-diphenyl[1]benzothieno[3,2-*b*][1]benzothiophene (DPh-BTBT). As previously reported for the monolayer pentacene, it was revealed that bunched steps on the vicinal Si(111) with a bismuth termination break the surface 3-fold symmetry and reduce the multiple orientation of the DPh-BTBT grains into a quasi-single orientation. Interestingly, the critical step height necessary for the orientation control was higher than that of pentacene. We examined several mechanisms of orientation control and concluded that the facet nanostructure fabricated by step bunching works as an anisotropic template for the nucleation. We also show the wettability optimization of the bismuth-terminated silicon surface and show that the growth mode of DPh-BTBT is dependent on the surface nanostructure of Bi–Si.



INTRODUCTION

As intensive efforts have been made to design novel high-mobility organic semiconductor molecules, there are growing numbers of newly synthesized molecules with a carrier mobility higher than 1 cm²/(V s). The benzothieno-benzothiophene derivatives, for example, are attracting much attention for their high mobility, air-stability, and good crystallinity.^{1,2} In order to develop an efficient strategy to design high mobility molecules, their fundamental parameters for carrier transport, such as transfer integrals, effective mass, and carrier-phonon coupling constant, should be evaluated through photoemission spectroscopy.

We have previously reported the epitaxial growth of the quasi-single crystalline pentacene with a “thin-film” phase polymorph on Bi-terminated Si(111) vicinal surfaces with a $\sqrt{3} \times \sqrt{3}$ reconstruction.³ Bismuth was previously found to be an ideal atom to terminate the surface dangling bonds of silicon, because the Bi–Si(111) surface is inert enough to grow pentacene in a “standing” orientation.⁴ It is the same orientation as those in practical field effect transistor (FET) devices, in which the molecular long axis of pentacene is almost perpendicular to the substrate surface. This is in clear contrast with metallic surfaces, on which a strong interaction between metal orbitals and molecular π orbitals make the molecules

“lying”. In our previous report, we have carried out the angle-resolved photoemission spectroscopy (ARPES) studies of the “thin-film” phase monolayer pentacene on Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$) and determined some of the important parameters like the effective mass and transfer integrals.⁵

However, the detailed mechanism of the quasi-single-oriented growth was not thoroughly understood, even though some possible mechanisms were suggested. Because the Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$) reconstructed surface has a 3-fold symmetry and the pentacene crystal has a triclinic lattice, it is more likely to obtain domains with six in-plane orientations in the epitaxial films. Our essential finding was that step bunching in the vicinal substrates seems to play an important role.

In this article, we report that the in-plane orientation control of 2,7-diphenyl[1]benzothieno[3,2-*b*][1]benzothiophene (DPh-BTBT; Figure 1a) is indeed possible as well on bismuth terminated Si(111) vicinal surfaces with bunched steps. We will also demonstrate that the wettability of DPh-BTBT is notably dependent on the Bi–Si nanostructure. By comparing the requirement for orientation control between pentacene and

Received: November 30, 2012

Revised: May 10, 2013

Published: May 13, 2013

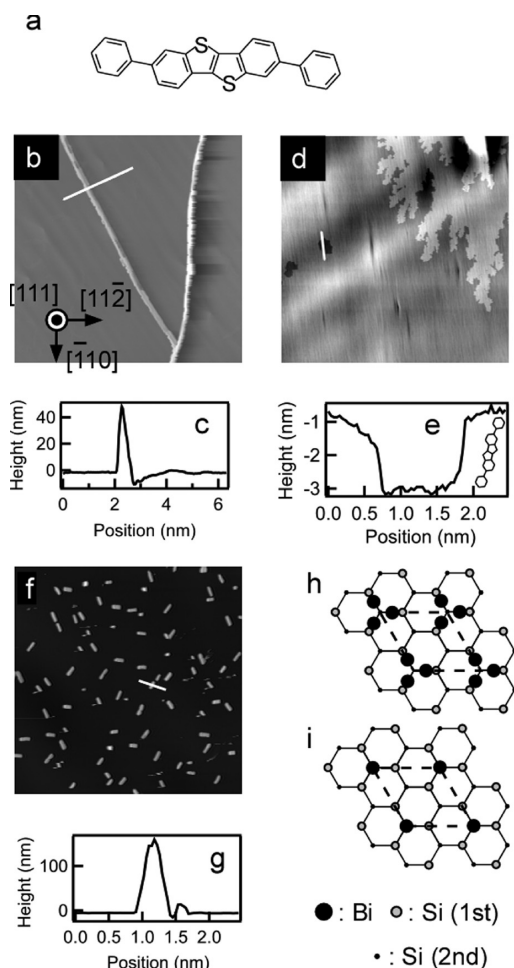


Figure 1. (a) Structural formula of 2,7-diphenyl[1]benzothieno[3,2-b][1]benzothiophene (DPh-BTBT). (b–g) AFM images and their cross section profiles of DPh-BTBT crystals grown on (b, c) β -phase (1 ML Bi), (d, e) α -phase (1/3 ML Bi), and (f, g) mixed phase (0.66 ML). (h, i) Schematic diagram of (h) β -phase and (i) α -phase Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$).

DPh-BTBT, we discuss the possible mechanism of orientation control on vicinal silicon surfaces with a heteroatom termination.

EXPERIMENTAL METHODS

The substrate was Si(111) with miscuts in various angles and directions. It was cleaned following the Shiraki method.⁶ The sample was mounted on a sample holder made of Mo, and introduced into a vacuum chamber equipped with a Knudsen cell, pyrometer, and reflection high energy electron diffraction with a microchannel plate (MCP-RHEED).⁷ The acceleration voltage and the typical sample current were 15 kV and 100 pA, respectively. First, the sample was thoroughly degassed overnight at 450 °C and then flashed at 1260 °C for 20 s. At 860 °C, the 1×1 reflection pattern turned into the 7×7 reconstruction, which was confirmed by RHEED. At this point, the pyrometer was calibrated to 860 °C. From 1260 to 960 °C, the sample was rapidly cooled in 1 min in order to avoid silicon carbide formation. From 960 to 800 °C, the sample was slowly cooled at the rate of 8 °C/min in order to promote step bunching.⁸ All of these processes were performed under $<2 \times 10^{-9}$ Torr vacuum conditions. Monolayer equivalent bismuth was then deposited from the Knudsen cell onto the substrate at

room temperature, and the 1×1 RHEED pattern was confirmed.

To turn 1×1 Bi into the $\sqrt{3} \times \sqrt{3}$ reconstructed surface, the sample was annealed after the Bi deposition. The coverage of Bi was estimated using ex situ X-ray photoemission spectroscopy by comparing the intensity ratio of the Bi 4f_{7/2} and Si 2p peak intensities. DPh-BTBT molecules, used as purchased, were subsequently deposited from the Knudsen cell. The substrate temperature was kept at 80 °C during the growth, which was the optimum value in terms of wettability and crystallinity.

Parts of the films were examined by Grazing Incidence X-ray Diffraction (GIXD; Rigaku SmartLab 9 kW with CuK α) under ambient conditions to determine the precise geometry of the reciprocal lattice.

RESULTS AND DISCUSSION

We first discuss the growth mode of the DPh-BTBT monolayer on the bismuth terminated silicon surface. Figure 1 shows the AFM images of the DPh-BTBT crystals grown on Bi–Si(111) with three surface nanostructures. It was reported that the post annealing temperature after the bismuth deposition is crucial for the nanostructure of the Bi–Si termination.^{9–12} When annealed at 350 °C, the surface dangling bonds are terminated by 1 ML bismuth and called the β -phase (so-called milk-stool model, Figure 1 h). On the other hand, annealing at 597 °C leads to low coverage of 1/3 ML, which is called the α -phase (Figure 1 i). The annealing temperature between 350 and 590 °C results in a mixture of α - and β -phases, which we call the mixed phase (~ 0.66 ML). As is clearly shown in Figure 1 b–g, the growth mode of the DPh-BTBT monolayer was dependent on the phases of the Bi–Si surfaces. For the β - and mixed phase, the monolayer equivalent DPh-BTBT was grown in the Volmer–Weber (VW) mode, that is, three-dimensional growth resulting in bulky needle crystals aligned in three directions, which reflect the surface 3-fold symmetry of the Bi–Si(111) surface. On the other hand, the α -phase surface seems to provide a lower contact angle with the DPh-BTBT films. The DPh-BTBT film was grown in a layer-by-layer mode in the first monolayer, followed by an island growth in the second layer and above (Stranski–Krahanow (SK) mode). This is in contrast to the growth of pentacene on Bi–Si(111); pentacene films were grown in the VW mode on the β -phase and in the SK mode on the α - and mixed phases.

The reason for the different wettability can be attributed to the surface energies of the α -, β -, and mixed phase surfaces. In the droplet model of the film growth, which we now adopt as a crude approximation, the contact angle θ of the adsorbed “droplet” can be determined as follows:

$$\cos \theta = \frac{\gamma_s - \gamma_i}{\gamma_f}$$

where γ_f , γ_s , and γ_i are the surface energy of the organic film, substrate surface, and interface energy, respectively.

To the best of our knowledge, there are no reports on the interface energy of DPh-BTBT/Bi–Si(111). Still, we can estimate the order of magnitude of γ_i by taking the adsorption energy of analogous systems into consideration. It was previously reported that the adsorption energy of pentacene on graphite was 1.14 eV.¹³ By taking the unit cell area of 110.1 Å² into account, this gives an interface energy of 0.17 J/m². Because the interaction between DPh-BTBT and Bi–Si(111) is

a van der Waals interaction, it is reasonable to assume that the interface energy of DPh-BTBT/Bi–Si(111) is on the same order of magnitude as, or even lower than, that of the pentacene/HOPG interface.

The surface energy of the α - and β -phase Bi–Si(111), on the other hand, was calculated by Kunc and co-workers using the density functional theory.¹⁴ The bismuth adsorption energy was evaluated by the energy gain of the system with respect to the total energy of the ideal (unreconstructed) Si(111)-(1 $\times$ 1) surface and isolated Bi atom. Interestingly, it was revealed that the α -phase Bi–Si is more unstable than the β -phase by 4.6 J/m², while Si(111)-(7 $\times$ 7) is even more unstable. It should be noted that the energy gain of 4.6 J/m² is 1 order of magnitude greater than the interface energy of the pentacene/graphite. Therefore, it is reasonable to assume that the increase in the surface energy of the α -phase lowers the contact angle between the DPh-BTBT and Bi–Si heterointerface.

It is relatively easy to qualitatively understand the instability of the α -phase. The α -phase surface is a considerably strained surface as previously reported.¹⁰ The largest displacement of the Si atoms in the α -phase reconstruction is as high as 0.20 Å, while that in the β -phase milk stool model is 0.11 Å. The instability of the α -phase is also reinforced by the fact that it can only be fabricated in a very narrow temperature range. The Bi atoms were easily desorbed by annealing at a temperature higher than 600 °C, which indicated the instability of the α -phase.

In the case of pentacene, on the other hand, the SK mode growth was also observed on the mixed phase surfaces. We have examined the growth of pentacene and DPh-BTBT on three types of Bi–Si(111) substrates (α -, β -, and mixture with different ratios) at various substrate temperatures and growth rates, and typical examples are described in this paper. The results indicated that the DPh-BTBT(001) surface is more unstable than the pentacene (001) surface, that is, DPh-BTBT molecules are more likely to segregate than the pentacene molecules, at elevated temperatures and on the α - and β -mixed surfaces.

Before discussing the in-plane orientation of DPh-BTBT on the bismuth terminated Si(111), we will briefly summarize our previous reports on the growth of the quasi-single crystalline pentacene monolayer on vicinal Si(111) with α -phase bismuth termination.³ Because the Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$) surface has a 3-fold symmetry, the triclinic ($\gamma = 89^\circ$) pentacene monolayer has six in-plane orientations, in which each two of them are twin crystals. The fundamental idea is to break the surface symmetry of Bi–Si(111). We employed the vicinally cut Si(111) surface inclined toward the $[11\bar{2}]$ direction and found out that step bunching is important to reduce the orientation of the pentacene. The 3 nm steps formed on the 2° off surface (Figure 2a) were required to reduce the in-plane orientation from 6 to 2, which are twin crystals. The role of the step bunching was not thoroughly understood, while the surface energy anisotropy of the pentacene model was considered unlikely, because the most unfavorable facet of pentacene crystal was parallel to the step edges.

DPh-BTBT was also grown in the quasi-three orientations on the flat Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$). It was easy to recognize for the needle crystals on the β -phase Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$) (Figure 2d). For the α -phase surface, on the other hand, there were no patterns or streaks confirmed with one monolayer thickness by MCP-RHEED. Another powerful method to determine the in-plane orientation of the monolayer grains was

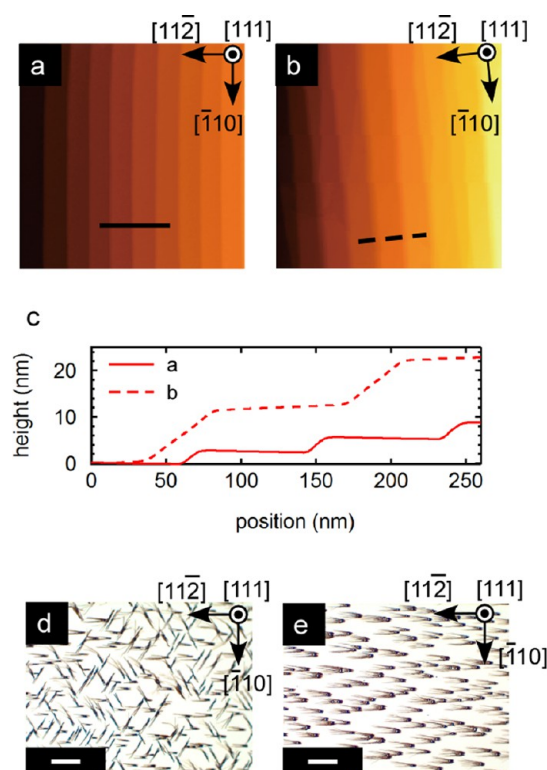


Figure 2. (a–c) AFM images and their cross section profiles of periodic bunched steps on (a) 2° off and (b) 4° off vicinal Si(111) surfaces inclined toward the $[11\bar{2}]$ direction. Steps with 3 and 10 nm heights can be fabricated from 2° off and 4° off vicinal surface, respectively, through gradual cooling of the sample after 1260 °C flash heating. (d, e) Optical microscope image of DPh-BTBT needle crystals grown on β -phase Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$) with (d) flat surface and (e) 10 nm steps (scale bar = 200 μm). As shown in (a–c), $[11\bar{2}]$ is the step descending direction.

recently developed by Frisbie and his co-workers.^{15,16} It is called transverse shear microscopy (TSM), analogous to friction force microscopy (FFM). The difference between TSM and FFM is the scanning direction. While friction parallel to the scanning direction is detected by conventional FFM, TSM utilizes the small transverse torsion of the cantilever which is perpendicular to the scanning direction. The TSM signal is high in the soft and anisotropic crystals like organic molecular crystals. It was reported that the TSM signal in the $[110]$ direction is the highest in the herringbone packing structure, which enables us to determine the orientation of each grain in the polycrystalline pentacene films. As DPh-BTBT also has a herringbone packing, we have carried out the TSM study of the DPh-BTBT grains on flat α -phase Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$). Figure 3a,b shows the AFM and TSM images of the DPh-BTBT monolayer on a flat substrate. It was confirmed that DPh-BTBT islands consisted of μm sized grains that are clearly shown in marked contrast difference in Figure 3b. There are three regions with discrete TSM signals: (i) 9 ± 3 mV, (ii) -5 ± 2 mV, and (iii) 4 ± 3 mV with respect to the substrate surface. This result indicates that the DPh-BTBT islands consisted of grains with at least three distinct orientations. However, the DPh-BTBT crystals grown on 3 nm steps, though, did not show any significant change in the TSM mapping. We found that the critical step height necessary to reduce the number of TSM plateaus from three to one was 10 nm, as indicated in Figure 3c,d, which was fabricated from 4°

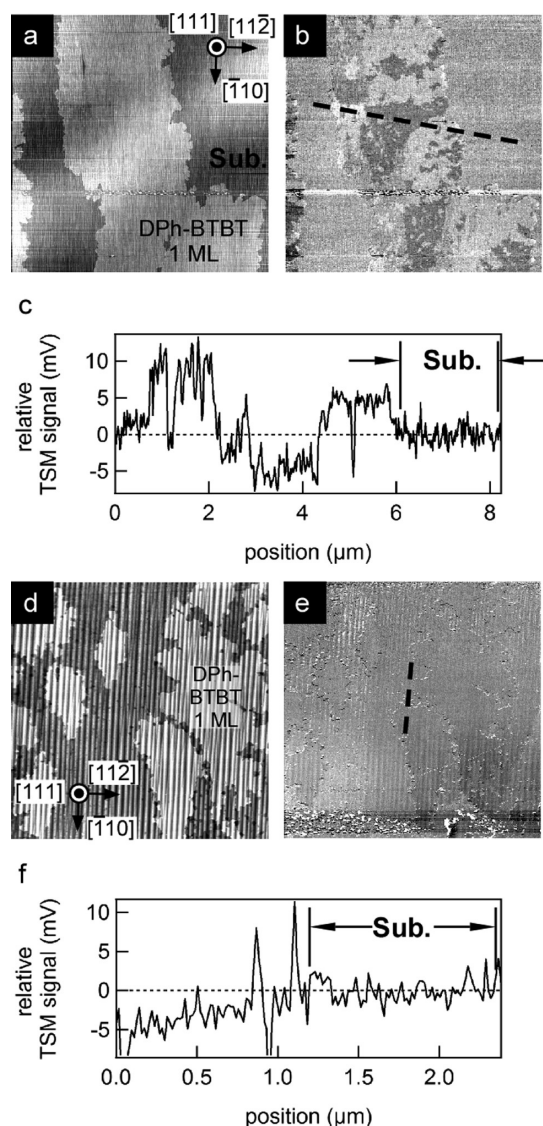


Figure 3. (a, b) AFM and TSM images of DPh-BTBT film on flat 1/3 ML Bi-Si(111)-($\sqrt{3} \times \sqrt{3}$), respectively. The monolayer island of DPh-BTBT in (a) was revealed to consist of several μm -size grains with three discrete TSM signals as shown in (b). The cross section along a dashed line in (b) is plotted in (c). (d, e) AFM and TSM image in case of 4° off-vicinal surface with 10-nm steps. In the TSM image (e), there were no contrasts within or between the grains. The cross section shown in (f) indicates that the selected grains have TSM signals of -5 mV with respect to the substrate. All TSM signals were replotted with respect to the bare substrate surface. Scanning area is $8 \times 8 \mu\text{m}^2$ in all the images.

off-substrate inclined toward the $[11\bar{2}]$ direction (Figure 2b). The TSM signals from the selected grains on the 10 nm steps were around -5 mV with respect to the bare substrate surfaces. To estimate the detailed orientation of the selected grains, we investigated the scanning orientation dependence. As we expected from the analogy to the pentacene orientation selection, we confirmed large TSM signals when the scanning direction was 40° from the step edges (Figure 4), which implies that the $[100]$ or $[010]$ direction of DPh-BTBT lattice was aligned with the edges.

A more quantitative analysis of the aligned crystal structure was performed using MCP-RHEED and GIXD (Glancing Incidence X-ray Diffraction) with the X-ray incidence almost

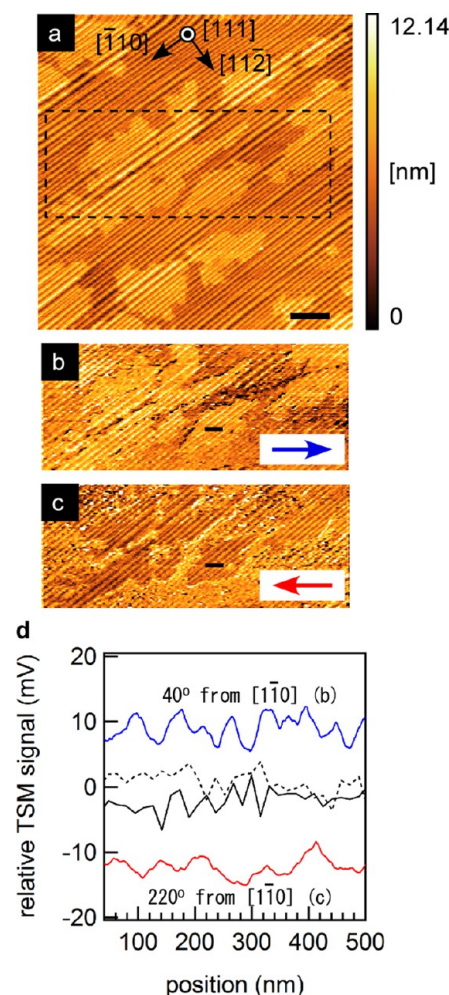


Figure 4. Scanning angle dependence of TSM signals of DPh-BTBT grains on 10 nm bunched steps. (a) Topography image (scale bar 1 μm), (b) TSM image with scanning direction 40° , and (c) 220° from Si $[1\bar{1}0]$. The cross section plot of TSM signals with respect to the substrate is shown in (d). Black solid and dashed lines in (d) is the TSM profile along the Si $[1\bar{1}0]$ and Si $[1\bar{1}\bar{0}]$, respectively. TSM signal along Si $[1\bar{1}0]$ was around 0 mV on average both in the forward and backward scans. Scanning at 40° from Si $[1\bar{1}0]$ direction showed a marked contrast between forward (40°) and backward (220°) scans. By assuming that the $\langle 110 \rangle$ direction of the DPh-BTBT lattice has the highest TSM signal, we can estimate that the $\langle 100 \rangle$ or $\langle 010 \rangle$ direction of the DPh-BTBT lattice is parallel to the Si $[1\bar{1}0]$ direction.

parallel to the surface. Figure 5a shows the MCP-RHEED pattern and Figure 5b shows the GIXD pattern. In the MCP-RHEED analysis, we obtained no apparent streaks or spots from DPh-BTBT on flat substrates. On the 4° off-vicinal substrates with 10 nm height steps, on the other hand, spots derived from DPh-BTBT were observed as shown in Figure 5a when the incidence angle of the electron beam was perpendicular to the step edges (parallel to Si $[11\bar{2}]$). This result is consistent with the TSM analysis, and the observed spot can be assigned as the (02) diffraction of DPh-BTBT. The GIXD pattern revealed, however, a rather broad peak of the (20) diffraction of DPh-BTBT. This result implies a relatively large lattice mismatch between DPh-BTBT and Bi-Si(111)-($\sqrt{3} \times \sqrt{3}$), resulting in an in-plane twisting up to 7° , corresponding to the broadening along the Phi direction in Figure 5b.

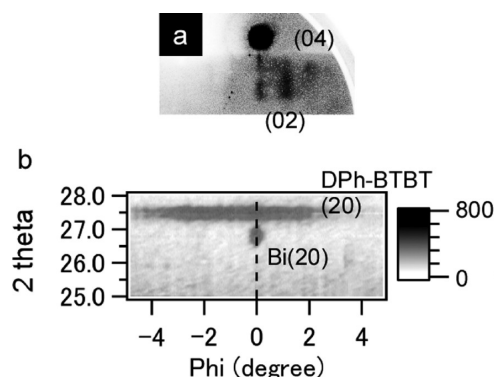


Figure 5. (a) MCP-RHEED and (b) GIXD patterns of monolayer DPh-BTBT films on 4° off $1/3$ ML Bi-Si(111)-($\sqrt{3} \times \sqrt{3}$) with 10 nm steps. In the MCP-RHEED pattern, two spots assigned as the (02) and (04) diffractions were observed when the electron beam was parallel to Si[112]. In the GIXD reciprocal mapping, a narrow spot assigned to the Bi(20) diffraction and wide (20) diffraction of DPh-BTBT were observed. The lattice constant derived from the (20) diffraction was $a = 0.65$ nm. The ϕ in (b) was defined as the angle between the scattering vector of the Bragg reflection and Si[112].

We propose three hypotheses for the orientation control mechanism on bunched steps. The first one is the kinetic selection of one orientation in which the speed of the crystal growth in the step descending or ascending direction prevail over those of the other directions. The second one is the mechanism similar to graphoepitaxy, which is a topographical effect of nanometer-size pitches or grooves on substrates. The last one is the “facet nucleation model”. In this model, we assume that facets, which are formed in the bunched steps region, have an anisotropic surface structure and work as a template for crystal growth.

The kinetics model is based on the anisotropic growth rate of the crystals on inclined surfaces, that is, the speed of the crystal growth in a certain direction prevails over those of the others, resulting mostly in monodomain films. It was reported that atomic steps on vicinally cut substrates can induce an anisotropic growth rate of pentacene grains.¹⁷ Even though each step has only one atomic height, the growth rate of the pentacene monolayer was faster in the step-descending direction than in the step-ascending direction, resulting in dendritic branches in the step-descending direction and a compact shape in the opposite one. The possible mechanism of this anisotropic growth is a kinetic process. We have previously reported from a pulsed molecular beam scattering experiment on an inclined H-Si(111) that surface residence time (SRT) was dependent on the direction of the incoming molecules: parallel to steps, ascending or descending.^{18,19} This result suggests that adsorption and desorption rates are not the same in the ascending and descending directions. Figure 6 depicts the needle crystals grown on 6 nm steps of β -Bi-Si(111)-($\sqrt{3} \times \sqrt{3}$). The crystals grown in the step ascending/descending (0°) direction perpendicular to the step edges were smaller than those in the other ($\pm 60^\circ$) directions, which indicates the effect of the kinetic process. That is, the growth speed in the 0° direction is slower than in the $\pm 60^\circ$ directions. When the step height was 10 nm, it is expected that the diffusion across these higher steps will be suppressed. A simple consideration will lead to the more suppression of the needle crystals in the 0° direction than those in the $\pm 60^\circ$ directions because of the higher necessity of diffusion across the steps. However, this

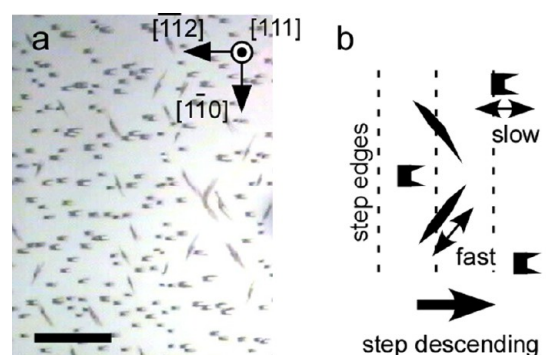


Figure 6. (a) Optical microscope image of DPh-BTBT needle crystals on 4° off Bi-Si(111) with 6 nm steps. The surface termination was confirmed to be the β -phase. Scale bar is 200 μm . (b) Schematic diagram of compact-shape crystals growing in step descending direction and long needle crystals in $\pm 60^\circ$ from Si[112].

expectation is contrary to the actual result shown in Figure 2e. Hence, other factors must be considered. The orientation of flat monolayer domains on stepped surfaces (Figure 3e) also cannot be explained by simple kinetic effects because asymmetric contours as in ref 17 were not observed.

The second hypothesis, the graphoepitaxy model, is analogous to the previous reports of graphoepitaxy.²⁰ To discuss this model, we present two results on the DPh-BTBT growth. First, it was revealed that the vicinal Si(111) inclined in [110] direction does not affect the orientation of the DPh-BTBT monolayer. Even when the steps were larger than 10 nm, the crystals were grown in three directions independent of the steps. Second, the antimony-terminated surface did not affect the growth of the crystals as well, regardless of the step height. The antimony terminated Si(111) was prepared following a previously reported procedure,²¹ which was reconstructed with the same $\sqrt{3} \times \sqrt{3}$ periodicity. Even though the steps were preserved after the antimony termination, steps did not affect the crystal growth at all. These two results indicate that the existence of only the geometrical guiding steps does not align the orientation of the DPh-BTBT lattice. That is, the atomic structure of the steps plays an important role.

The remaining hypothesis is the “facet nucleation model” illustrated in Figure 7. We consider that it can provide a reasonable explanation without any inconsistency. It is based on the accidental lattice matching of the growing molecules with that of the facets. For the bare Si(111)-(7×7), high resolution scanning tunneling microscopy (STM) studies revealed that the bunched steps form Si(331) facets in the 10° off-Si(111) surface,^{22–24} while no obvious periodicity was observed in the 2° off-surface.²⁵ Si(331) is the only stable surface existing between Si(111) and Si(110), as a consequence of the stable 12×1 reconstruction. This hypothesis is based on the fact that the surface lattice constant of Si(331)-(1×1) is 0.384×0.860 nm², which matches very well with the lattice constant of the thin-film phase pentacene ($b = 0.759$ nm) with a mismatch of 1%. Therefore, it is reasonable to assume that the Si(331) or analogous nanostructure in the facets is working as an anisotropic template for the crystal growth. For DPh-BTBT, although the single crystal structure has not yet been solved yet, our MCP-RHEED analysis of the (11) diffraction revealed $b = 0.75$ nm, which gives a 2.4% mismatch with Si(331)-(1×1).

The mechanism of the orientation with this model is as follows. The molecular crystals (pentacene or DPh-BTBT)

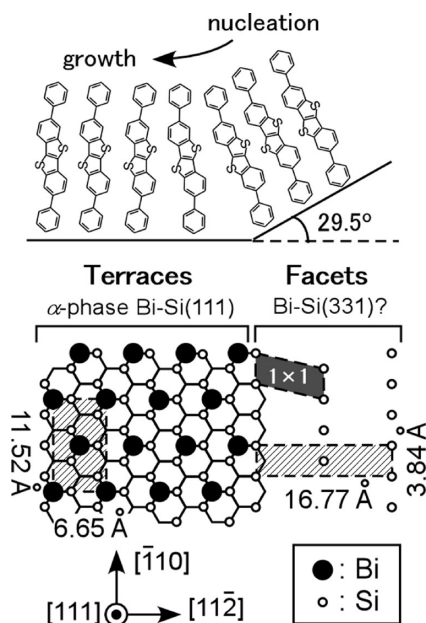


Figure 7. Schematic diagram explaining the “facet nucleation model”. The facets assuming a Si(331) structure are superimposed on the terraces.

nucleates only on the facets because of the excellent lattice matching with the facet lattice. Nevertheless, if the critical nuclei size is greater than the facet size, nucleation will not occur. Because the height of the steps is proportional to the facet size, the probability of the nucleation is governed by the step heights. It is understood that the alignment of pentacene requires a smaller step height than DPh-BTBT because the lattice matching of pentacene is much better.

The effects of bismuth adsorption onto the facets of the vicinal Si(111) have not yet been investigated. However, we reinforce our hypothesis by presenting two additional experimental results as follows, which will be described in detail in a forthcoming paper. First, Bi–Si(331) have a stable surface with 5×1 reconstruction. Second, Sb–Si(331) do not have a stable surface reconstruction. The RHEED pattern of Sb–Si(331) was that of the amorphous halo pattern until the desorption. This is probably the reason why the Sb-terminated vicinal surface did not affect the in-plane orientation; it did not have a nucleation template on the facets. Whereas a full understanding of the mechanism requires high-resolution STM studies of the bismuth terminated Si(111) vicinal surfaces, the most reasonable hypothesis presented so far seems to be the “facet nucleation model”.

CONCLUSION

In this article, we have demonstrated that the growth mode and crystal orientation of DPh-BTBT is controlled through manipulating the nanostructure of the bismuth terminated Si(111) surface. The growth mode was significantly dependent on the coverage of the bismuth atoms; Volmer–Weber mode on 1 ML bismuth (β -phase) and Stranski–Krastranow mode on $1/3$ ML (α -phase). The reason for this difference can be attributed to the high surface energy of the α -phase surface, which is derived from the strained structure of the Bi–Si termination. It was also revealed that bunched steps as high as 10 nm on the 4° off-vicinal surfaces inclined toward the $[112]$ direction are necessary to make quasi-single crystalline DPh-

BTBT films on Bi–Si(111)-($\sqrt{3} \times \sqrt{3}$), while pentacene needed 3 nm steps as previously reported. The mechanism for orientation control and critical step height difference was successfully explained by the “facet nucleation model”, in which the facet structure in bunched steps, possibly analogous to Si(331), plays an important role. This result enables us to fabricate films with a well-defined crystal orientation on conductive substrates and accelerate spectroscopic studies of newly developed organic semiconductors.

AUTHOR INFORMATION

Corresponding Author

*Tel.: +81-29-284-3802 (M.O.); +81-11-706-6576 (T.S.). E-mail: ohtomo.manabu@jaea.go.jp (M.O.); shimadat@eng.hokudai.ac.jp (T.S.).

Notes

The authors declare no competing financial interest.

ACKNOWLEDGMENTS

We thank Prof. Kazuo Takimiya (Hiroshima Univ.) for his fruitful discussion. This work was supported by the Global Centers of Excellence (GCOE) Program “Chemistry Innovation through Cooperation of Science and Engineering” and Grant-in-Aid for JSPS Fellows from the Japan Society for the Promotion of Science (JSPS).

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